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## APPLICANTS

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\*\* CONTINUING DATA \*\*\*\*\*

None TSP

\*\* FOREIGN APPLICATIONS \*\*\*\*\*

yes / TSP

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35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after				
Verified and Acknowledged	Examiner's Signature <i>Alloppa</i>	Initials <i>TSP</i>		

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## TITLE

Thin film semiconductor device and manufacturing method

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT	<input type="checkbox"/> All Fees
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